

Docket No. 209284US99

JAN 30 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Zhiyi YU, et al.

SERIAL NO: 09/842,734

GAU: 2811

FILED: April 26, 2001

EXAMINER: HU, SHOUXIANG

FOR: STRUCTURE AND METHOD FOR FABRICATING SEMICONDUCTOR STRUCTURES AND DEVICES USING BINARY METAL OXIDE LAYERS

EXPRESS ABANDONMENT UNDER 37 CFR 1.138

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

Applicant(s) wish to disclose the following information.

☒ **Express Abandonment**

Applicant's Representative requests that the above-identified application be expressly abandoned as of the filing date of this paper.

☐ **Express Abandonment in Favor of a Continuing Application**

Applicant's Representative requests that the above-identified application be expressly abandoned as of the filing date accorded the continuing application filed herewith.

☐ **Petition for Express Abandonment to Avoid Publication under 37 C.F.R. 1.138(c)**

Applicant's Representative hereby petitions to expressly abandon the above-identified application under 37 CFR 1.138(c) to avoid publication.

The required petition fee under 37 CFR 1.17(h) of \$130.00 is enclosed herewith by credit card payment form and any further charges may be made against the Attorney of Record's Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.

Richard L. Treanor

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Adjustment Date: 05/09/2006 SDIRETA1

01/31/2006 HBEYENE2 00000054 09842734

01 FC:1464 -130.00 OP

Refund Ref:
05/09/2006

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Credit Card Refund Total: \$130.00

Am Exp.: XXXXXXXXXXXX1008



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IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF

ZHIYI YU, ET AL.

: EXAMINER: HU, SHOUXIANG

SERIAL NO: 09/842,734

FILED: APRIL 26, 2001

: GROUP ART UNIT: 2811

FOR: STRUCTURE AND METHOD FOR
FABRICATING SEMICONDUCTOR
STRUCTURES AND DEVICES USING
BINARY METAL OXIDE LAYERS

REQUEST FOR REFUND

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

Applicants request a refund in the amount of \$130.00 for the Express Abandonment Under 37 CFR 1.138 fee paid in error on January 30, 2006, in the above-identified application. Applicants request a refund as the fee is only required with a petition to avoid publication of the application.

Please credit the refund to our Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.

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